

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: DiCarlo *et al.*
Application No.: 11/750,142
Filed: 12/31/2003
For: Method for Removal of Pattern Resist
Over Patterned Metal Having an
Underlying Spacer Layer

Docket: TI-36187
Examiner: Vinh, Lan
Art Unit: 1765
Conf. No.: 7928

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

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I hereby certify that the above correspondence is being filed electronically with the U.S. Patent and Trademark Office on the date indicated below.

/Sue Short/ 12/21/07
Sue Short Date

Dear Sir:

In response to the Notice of Allowance and Fee(s) Due mailed October 4, 2007, Applicants submit the following comments:

REMARKS

The Applicants agree with the Examiner's conclusions of patentability, without necessarily agreeing with or acquiescing in the Examiner's reasoning or comments. The Applicants submit that the claims of the above-identified application are allowable because the prior art fails to anticipate or render obvious the invention as claimed.

Respectfully submitted,

/Charles A. Brill/
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